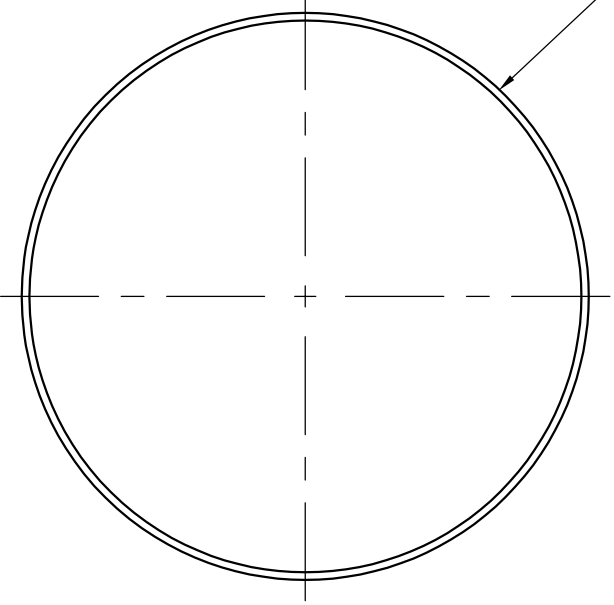


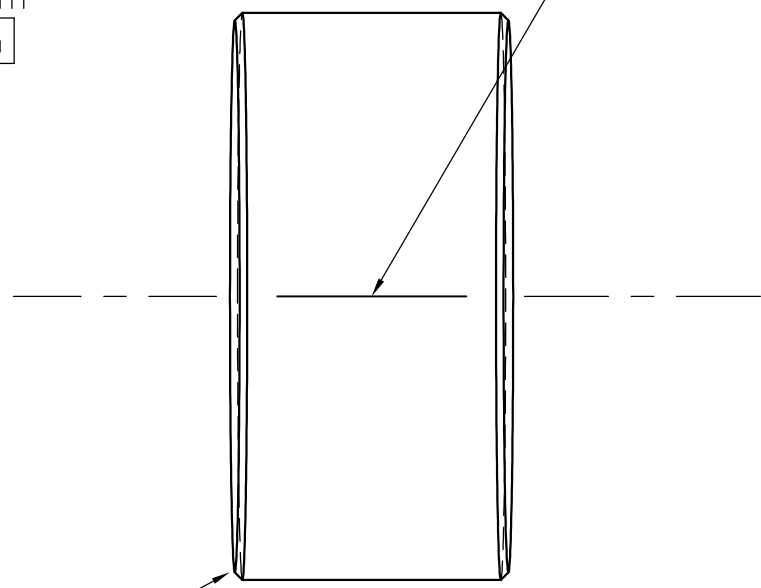
ETCH OR GRIND 0.25mm±0.05mm
 WIDE X 50mm±1mm LONG
 3 PLACES 90°±15' APART FROM
 LINE WITH ARROW (SEE TOP VIEW)
 PARALLEL TO CENTRAL AXIS WITHIN
 ±0.10mm, CENTERED BETWEEN
 FRONT AND REAR SURFACES

75^{+0.0}_{-0.5} THICK
 AT THEORETICAL
 SHARP CORNER
 BEFORE
 CHAMFERING

ETCH, GRIND, OR SANDBLAST SERIAL
 NUMBER AND ORIENTATION ARROW



∅150 +1mm
 -0mm
 0.1mm



CHAMFER
 45°±1° X 2±0.3
 2 PLACES

UF LIGO WILLIAMS, LUKE	ALIGO INPUT MODE CLEANER MIRROR #3 SUBSTRATE	SCALE: HALF (mm)		DATE: APRIL 1, 2008
		D070093-01	QTY: 4	MATERIAL: FUSED SILICA OAA